

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Mei Wen et al.
Serial No. : 10/676,208
Filed : October 1, 2003
For : METAL DEPOSITION PROCESS WITH PRE-
CLEANING BEFORE ELECTROMECHANICAL
DEPOSITION
Examiner : Edna Wong
Group Art Unit : 1753
Customer No. : 41161
Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Examiner's Office Action dated February 27, 2007, Applicants amend the above-identified application as follows:

Amendments to the Specification begin on page 2.

Amendments to the Claims begin on page 3.

Remarks begin on page 7.